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067951

PATENT NUMBER and  
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10067951	02/05/2002	438	298	2814	T. DOAN

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CONTINUING DATA VERIFIED: NONE, TD

\*\* FOREIGN APPLICATIONS VERIFIED: YES, TD

REPUBLIC OF KOREA 2001-56504 09/13/2001

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PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☒ yes ☐ no

35 USC 119 conditions met ☒ yes ☐ no

Verified and Acknowledged Examiners's initials TD

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CU-2765 VE

TITLE: Method for fabricating a capacitor

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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